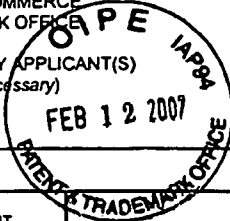


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			APPLICANT DAISUKE MIURA, et al.				
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/J.M./		7,094,625	08/22/06	Miura, et al.	438	99	/
		2006/0214159	09/28/06	Nakayama, et al.	257	40	
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FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
/J.M./		5-190877	07/30/93	Japan			Abstract
/J.M./		5-55568	03/05/93	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
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EXAMINER /Julio Maldonado/				DATE CONSIDERED 12/19/2007			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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